Nickel catalysed Coupling of Phenylhydrosilanes

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Activated nickel, prepared by lithium reduction of nickel iodide in tetrahydrofuran, catalyses the dehydrogenative coupling of phenysilanes to form di-, tri- and tetrasilanes.

Only recently have catalytic methods of forming siliconsilicon bonds been developed.' Herein we report the first example of heterogeneously catalysed dehydrogenative coupling of hydrosilanes.2

The rate of generation and the activities of freshly prepared powders can be significantly enhanced when they are produced in an ultrasonic field.3 We have found that nickel powder, freshly prepared from nickel iodide and lithium dispersion in tetrahydrofuran (THF) in the presence of ultrasonic waves, catalyses the formation of Si-Si bonds from phenyl-substituted hydrosilanes. Diphenylsilane, for example, when treated with one mole percent each of activated nickel and triphenylphosphine at 80° C gives a 45% yield of sym-tetraphenyldisilane in $3-4$ h.^{4†} However, when phenylmethylsilane is used under the same conditions, a broader distribution of products is obtained (eqn. 1). The reaction does not require triphenylphosphine, although lower yields (15, 25, 7 and 2% respectively) are obtained without it. No (15, 25, / and 2% respectively) are obtained without it. No
higher polysilanes were observed. Commercially available
nickel powder gave no coupling products with or without
triphenylphosphine.
PhMeSiH₂ $\frac{Ni^*}{Ph_3P}$ nickel powder gave no coupling products with or without triphenylphosphine .

$$
\begin{array}{ll}\n\text{PhMeSiH}_{2} \frac{\text{Ni}^{*}}{\text{Ph}_{3}P} \\
\text{PhMeHSi-SiHMePh} & + \text{PhMeHSi-SiMePh-SiHMePh} \\
& 20\% & 40\% \\
\text{PhMeHSi-(SiMePh})_{2} - \text{SiHMePh} + \text{Ph}_{2} \text{MeSiH} \\
& 25\% & < 3\% \\
\end{array}
$$
\n(1)

t Typically, the silane : solvent mole ratio is 1 : 4. All yields are GC yields using an internal standard and when combined with unreacted starting material the mass balance for silicon is >90%.

While it is premature to set down a detailed mechanism, we suggest that oxidative addition of the hydrosilane4 to nickel followed by reductive elimination of the Si-Si species and H_2 is a reasonable pathway and is consistent with our observations (Scheme 1).

The Raman spectrum of activated nickel exposed to PhSiH₃ is presented in Fig. *la.* For comparison, the spectrum of trideuteriophenylsilane, $PhSiD₃$, is given in Fig. 1b. The

Fig. 1 Raman spectra of activated nickel and phenylsilane in THF suspension: *a* PhSiH₃; *b* PhSiD₃

important difference between the two spectra is the presence of a strong band at 1947 cm⁻¹ in $1a$ and its conspicuous absence and replacement with a less intense absorption at 1543 cm^{-1} in 1b. An isotopic shift of this sign and magnitude is consistent with simple replacement of \overline{H} in a nickel hydride with D.⁵ Thus, we assign the band at 1947 cm⁻¹ to the Ni-H vibration.6 To our knowledge this is the first spectroscopic evidence in support of the oxidative addition of silicon hydride to nickel.

Our preliminary studies point to a surface species as the catalytic agent. Rinsing of freshly prepared nickel with solvent followed by extensive pumping on a high vacuum line does not

1900 2100 destroy the catalyst. The role of the triphenylphosphine increasing the yields of coupled products is unclear at this stage. It is reasonable that the donor capabilities of triphenyl-
1947 1947 destroy the catalyst. The role of the triphenylphosphine in increasing the yields of coupled products is unclear at this phosphine enhance the insertion of nickel into the Si-H bond.

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